## Notic of References Cited Application/Control No. 10/617,030 Examiner Sophia S. Chen Applicant(s)/Patent Under Reexamination FUJIWARA, YUMI Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5,017,969	05-1991	Mitomi et al.	198/835(X)
	В	US-6,053,307	04-2000	Honda, Katsuya	198/840(X)
	O	US-6,097,922	08-2000	Munenaka, Katsumi	399/303(X)
	D	US-2002/0021920 A1	02-2002	Hayakawa et al.	399/303
	ш	US-2002/0046932 A1	04-2002	Wakana, Takashi	198/840
	F	US-6,453,143	09-2002	Takeuchi, Kazutaka	399/303
	O	US-2003/0175056 A1	09-2003	Sato et al.	399/302
	Η	US-			
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	02-157769	06-1990	Japan	Aoki	/
	0	09-114266	05-1997	Japan	Kodama	/
	Р	09-169445	06-1997	Japan	Ito et al.	/
	Q	10-254252	09-1998	Japan	Enomoto	/
	R	2000-075579	03-2000	Japan	Ichihara	/
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U					
	٧					
	w					
	x					

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.